

5/18/07

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> ( Not for submission under 37 CFR 1.99)	Application Number		10663402	
	Filing Date		2003-09-16	
	First Named Inventor	Warren M. Farnworth		
	Art Unit	1773		
	Examiner Name	V. Chen		
	Attorney Docket Number	2269-5595US (01-0088.00/)		

Examiner Initial*	Cite No	Publication Number	Kind Code <sup>1</sup>	Publication Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
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NC/	1	Wikipedia entry "Rapid prototyping" webpage printed 5/23/2006, 3 pages	<input type="checkbox"/>
NC/	2	DURHAM, MIKE, "Rapid Prototyping Stereolithography, Selective Laser Sintering, and Polyjet," Advanced Materials & Processes, January 1, 2003, Vol. 161(1), Page 40 (Article Excerpt), ASM International, Materials Park, Ohio	<input type="checkbox"/>

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#### EXAMINER SIGNATURE

Examiner Signature	/Vivian Chen/	Date Considered	05/29/2007
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